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APPLICANT

Chan et al.

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1645

Sheet 1 of 1

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U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPRO- PRIATE
✓	1	6,248,539	06/19/01	Ghadiri et al.		

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JUN 05 2002

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FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRAN- SLATION IF APPRO- PRIATE

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

✓	2	Chan et al., "Porous Silicon Microcavities for Dye-sensing Applications," <i>Physica Status Solidi A</i> 182:541-546 (2000)
	3	Chan et al., "Nanoscale Silicon Microcavity Optical Sensors for Biological Applications," <i>Material Research Society Proceedings Symposium F</i> (Vol. 638) F10.4 (2000)
	4	Chan et al., "Identification of Gram Negative Bacteria Using Nanoscale Silicon Microcavities," <i>J. Am. Chem. Soc.</i> 123(47):11797-11798 (2001)
	5	Chan et al., "Tunable, Narrow, and Directional Luminescence From Porous Silicon Light Emitting Devices," <i>Applied Physics Letters</i> 75(2):274-276 (1999)
	6	Chan et al., "Nanoscale Microcavities for Biomedical Sensor Applications," In <i>Micro- and Nanotechnology for Biomedical and Environmental Applications</i> , Proceedings of SPIE, 3912:23-34 (2000)
	7	Chan et al., "Silicon Interference Filters and Bragg Reflectors for Active and Passive Integrated Optoelectronic Components," <i>SPIE Conference on Silicon-Based Optoelectronics</i> , San Jose, California, 3630:144-154 (1999)
✓	8	Chan et al., "Porous Silicon Multilayer Mirrors and Microcavity Resonators for Optoelectronic Applications," <i>Material Research Society Proceedings Symposium</i> , 536:117-122 (1999)
EXAMINER		DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

